

FIG. 1

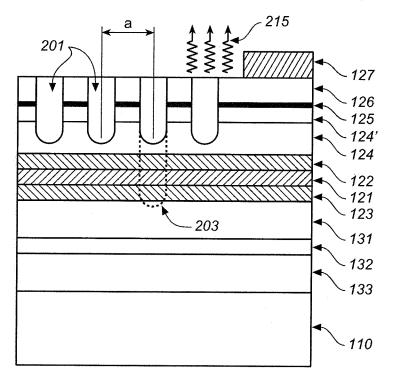
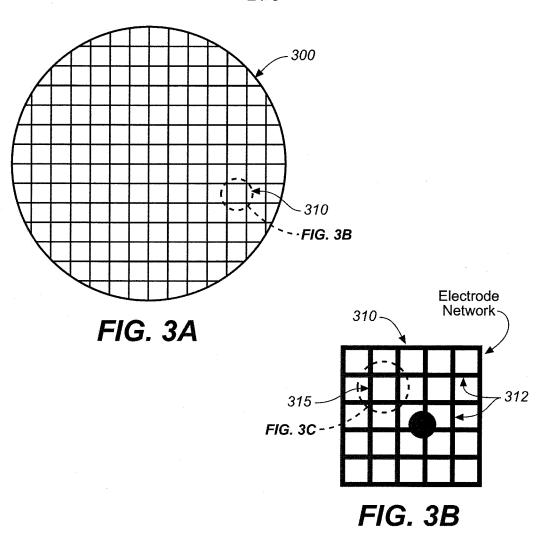
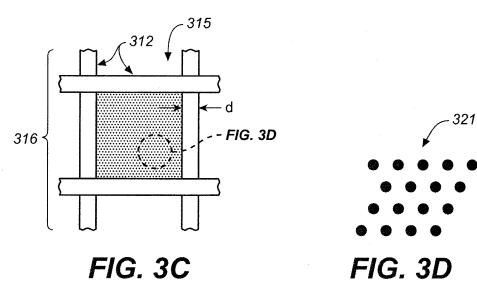


FIG. 2

Appln. No. 10/773,943 VIA EFS Filing Date: 02/06/2004
Title: Light Emitting System with High Extraction Efficiency
Inventor: Ho-Shang LEE et al. Atty Docket: DICO.049US0
REPLACEMENT SHEET - 2/5

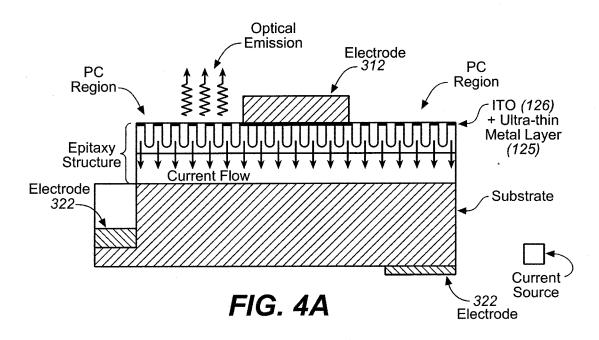
2/5

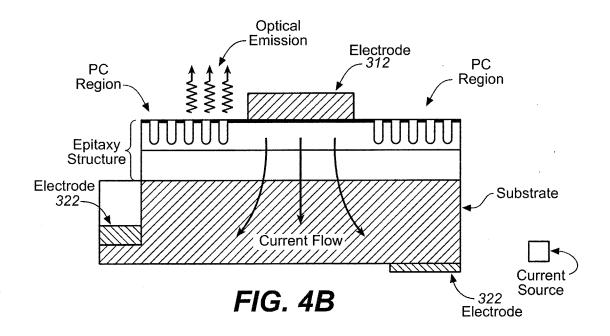




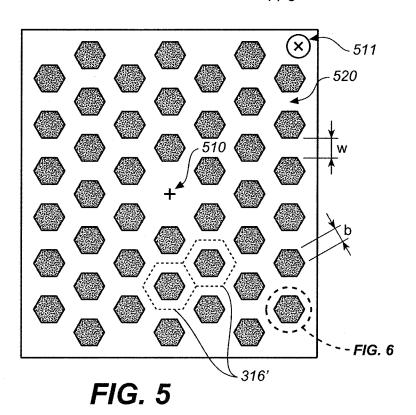
Appln. No. 10/773,943 VIA EFS Filing Date: 02/06/2004
Title: Light Emitting System with High Extraction Efficiency
Inventor: Ho-Shang LEE et al. Atty Docket: DICO.049US0
REPLACEMENT SHEET - 3/5

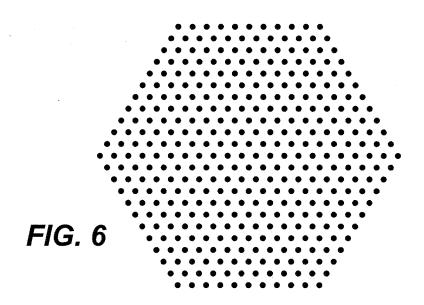
3/5





4/5





Appln. No. 10/773,943 VIA EFS Filing Date: 02/06/2004
Title: Light Emitting System with High Extraction Efficiency
Inventor: Ho-Shang LEE et al. Atty Docket: DICO.049US0
REPLACEMENT SHEET - 5/5

5/5

Mold 1. Make Mold and Apply Resist FIG. 7A Resist Substrate 2. Imprint Press Mold FIG. 7B Remove Mold FIG. 7C Pattern Transfer by Etching FIG. 7D FIG. 7E 4. Etch Holes